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15 1792



Patent
Attorney Docket 4439

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:	Nobuhiro Hayashi, Takayoshi Hirono)	
	Isao Tada, Atsushi Nakatsuka)	
)	
Application No.:	10/574,715)	
)	
Filed:	March 27, 2006)	Smith, Francis P.
)	Patent Examiner
)	Art Unit 1792
For:	Vacuum Evaporation Deposition Method)	
	of the Winding Type and Vacuum)	
	Evaporation Deposition Apparatus of the)	
	Same)	
			Pittsburgh, Pennsylvania

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This Amendment is filed in response to the Non-Final Office Action dated April 14, 2008.

Kindly consider the following amendments to the specification and the following remarks.